

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

PATENT APPLICATION

Inventors: Apostolos T. Voutsas, Robert S.  
Sposili, and Mark A. Crowder

Serial No: Not Yet Assigned

Attorney Docket No.  
SLA0809

Filed: Herewith

Title: METHOD AND PROCESS FOR  
LONG CRYSTAL LATERAL  
GROWTH IN SILICON FILMS BY UV  
AND IR PULSE SEQUENCING

Hon. Commissioner for Patents  
Washington, D.C. 20231

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97**

Sir:

Listed on attached Form PTO-1449 is information submitted pursuant to  
37 C.F.R. §1.56. A copy of each listed publication is submitted herewith.

Applicant respectfully requests that the listed information be considered by  
the Examiner and made of record in the above-identified application.

November 13, 2003  
(Date)

Respectfully submitted,



Matthew D. Rabdau  
Reg. No. 43,026

Matthew D. Rabdau, Patent Attorney  
Sharp Laboratories of America, Inc.  
5750 NW Pacific Rim Boulevard  
Camas, WA 98607  
Telephone: (360) 834-8567  
Facsimile: (360) 817-8505

FORM PTO-1449  INFORMATION DISCLOSURE CITATION IN AN APPLICATION			DOCKET NUMBER SLA0809		APPLICATION NUMBER  APPLICANT Apostolos T. Voutsas, Robert S. Sposili, and Mark A. Crowder	
			FILING DATE: November 13, 2003		GROUP ART UNIT	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILE. DATE IF APPROP.
	6,645,454	11/11/03	Voutsas			
	6,635,555	10/21/03	Voutsas			
	6,590,228	7/8/03	Voutsas <i>et al.</i>			
	6,495,405	12/17/02	Voutsas <i>et al.</i>			
	6,635,554	10/21/03	Im <i>et al.</i>			
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY/NAME	CLASS	SUB CLASS	TRANSLATION YES NO
OTHER DOCUMENTS						
	Proceeding entitled, "CO2 LASER CRYSTALLIZATION OF SILICON ON BULK FUSED SILICA", by Hawkins <i>et al.</i> , published in Material Research Society Symposia Proceedings Vol. 4, pp 529-534, 1982					
EXAMINER			DATE CONSIDERED			